



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

June 17, 2026

IGI Report Number

LG810610661

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

CUT CORNERED RECTANGULAR MODIFIED BRILLIANT

Measurements

7.52 X 5.29 X 3.53 MM

GRADING RESULTS

Carat Weight

1.22 CARAT

Color Grade

E

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

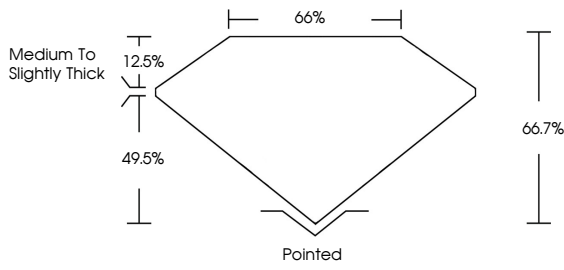
Inscription(s)

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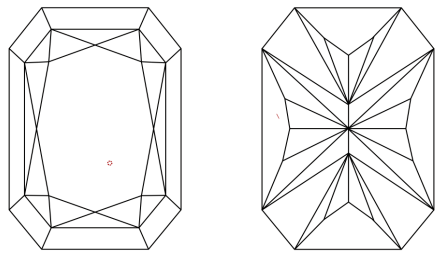
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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CUT CORNERED RECT. MODIFIED BRILLIANT

7.52 X 5.29 X 3.53 MM

Carat Weight

1.22 CARAT

Color Grade

E

Clarity Grade

VS 1

Depth

49.5%

Table

12.5%

Girdle

Medium to Slightly Thick

Culet

Pointed

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

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